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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Sukharev, Catabay
Title: Viscous Electropolishing System
Filing date: 2001.12.21
Express mail number: EL 511 138 675 US
Attorney docket: 01-822



INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97

Assistant Commissioner for Patents
Washington DC 20231

Sir:

The enclosed documents are submitted in compliance with 37 C.F.R. §§ 1.97 and 1.98. Also enclosed is a form PTO-1449 listing the citations. By this submission Applicant is not admitting the materiality of these citations; they are merely submitted to ensure full compliance with 37 C.F.R. § 1.56.

Sincerely,

LUEDEKA, NEELY & GRAHAM, P.C.

By: 

Rick Barnes, 39,596

2001.12.21

P.O. Box 1871
Knoxville TN 37901

T:1.865.546.4305
F:1.865.523.4478

RBarnes@LNG-Patent.com

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FORM PTO-1449
INFORMATION DISCLOSURE CITATIONS
IN AN APPLICATION

Atty Docket: 01-822 Serial #:
Applicant: Sukharev, Catabay
Filing Date: 2001.12.21 Group:

12/21/01
U.S. PTO
10/03/02
12/21/01

U.S. PATENT DOCUMENTS

| Examiner Initial | Cite # | Document Number | Date | Name | Class | Sub-Class | Filing Date |
|------------------|--------|-----------------|------|------|-------|-----------|-------------|
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FOREIGN PATENT DOCUMENTS

| Examiner Initial | Cite # | Document Number | Date | Country | Class | Sub-Class | Translation |
|------------------|--------|-----------------|------|---------|-------|-----------|-------------|
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OTHER NON-PATENT DOCUMENTS

| Examiner Initial | Cite # | Author, title, date, pertinent pages, etc. |
|------------------|--------|--|
| | 1 | Wang et al., Stress-free polishing advances copper integrated with ultralow-k dielectrics, Solid State Technology, pp.101-106, October 2001. |

Examiner

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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